



H-997

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

T. DANNO et al.

Group Art Unit: 2823

Serial No. 09/910,833

Examiner: F. Toledo

Filed: July 24, 2001

For: A SEMICONDUCTOR DEVICE MANUFACTURING METHOD WHEREIN  
ELECTRODE MEMBERS ARE EXPOSED FROM A MOUNTING  
SURFACE OF A RESIN ENCAPSULATOR (As Amended)

**REQUEST TO CORRECT NOTICE OF ALLOWANCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 3, 2004

Sir:

Please correct the Notice of Allowance mailed July 12,  
2004 as follows:

In the title, please change "SEMICONDUCTOR DEVICE  
ANUFACTURING METHOD WHEREIN ELECTRODE MEMBERS ARE EXPOSED FROM  
A MOUNTING SURFACE OF A RESIN ENCAPSULATOR" TO --**Semiconductor  
Device Manufacturing Method Wherein Electrode Members are  
Exposed From a Mounting Surface of a Resin Encapsulator--.**

In addition, Applicants respectfully request that the  
Examiner acknowledge the Information Disclosure Statement and  
PTO Form 1449 filed on December 16, 2003 on the corrected  
Notice of Allowability.

The undersigned requests that a corrected Notice of Allowance be issued.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Daniel J. Stanger", is written over the printed name.

Daniel J. Stanger  
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